



COURSE DESCRIPTION CARD - SYLLABUS

Course name

Optical Microscopy [S1ETI1>MO]

Course

Field of study

Education in Technology and Informatics

Year/Semester

3/5

Area of study (specialization)

–

Profile of study

general academic

Level of study

first-cycle

Course offered in

polish

Form of study

full-time

Requirements

elective

Number of hours

Lecture

26

Laboratory classes

0

Other (e.g. online)

0

Tutorials

0

Projects/seminars

0

Number of credit points

2,00

Coordinators

dr Andrzej Jarosz

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Lecturers

Prerequisites

Knowledge of experimental physics and mathematics at the undergraduate engineering course level. Skill in elementary physical problem solving, skill in acquiring information from listed sources. Understanding the necessity of continuous self-improvement.

Course objective

1. Acquaintance of the students with the basic geometric and wave optics problems with special consideration of optical microscope construction and application in science and technology. 2. Development of skills in knowledge of physics application to the analysis of optical instruments construction and operation. 3. Development of students abilities to acquire information and arrange self-education process.

Course-related learning outcomes

Knowledge:

1. student, who has completed the course, is able to explain structure and principle of operation of selected optical instruments especially optical microscope - [k1_w02]
2. student, who has completed the course, is able to define parameters of components commonly

applied to optical microscopes constructions - [k1_w10, k1_w13]

Skills:

1. student, who has completed the course, is able to acquire from literature, databases and other sources information concerning materials, sub-assemblies and modules essential to develop simple optical instrument - [k1_u01]
2. student, who has completed the course, is able to calculate selected parameters of developed instrument - [k1_u04, k1_u08]
3. student, who has completed the course, is able to define parameters of the system for optical microscopy paying special attention to its application in selected fields of science and technology - [k1_u16, k1_u23]

Social competences:

1. student, who has completed the course, demonstrates activity in professional competence self-improvement - [k1_k03]
2. student, who has completed the course, understands the need of technical knowledge transfer to the fields important from the public interest point of view, like environmental protection, health care and is aware of the special role of technical university graduates in this process - [k1_k06, k1_k09]

Methods for verifying learning outcomes and assessment criteria

Learning outcomes presented above are verified as follows:

Learning outcomes presented above are verified as follows:

W01, W02, U01, U02, U03, K01, K02

Assessment of knowledge demonstrated during written test on the basis of scored points:

3,0 50,1%-70,0%

4,0 70,1%-90,0%

5,0 od 90,1%

Programme content

1. Geometric and wave optics fundamentals.
2. Properties of optical materials. Phenomena at a boundary of optical media.
3. Basic optical components. Lenses and mirrors - types and parameters. Optical filters. Polarizers - basic properties.
4. Image formation by mirrors, lenses and lens systems.
5. Optical aberrations.
6. Photometric and radiometric quantities.
7. Light sources and their properties.
8. Detectors of light, image acquisition systems.
9. Construction of optical microscope. Types of optical microscopes.
10. Polarization Microscopy
11. Phase Contrast Microscopy
12. Differential Interference Contrast Microscopy
13. Fluorescence Microscopy
14. Confocal Microscopy
15. Application of optical microscopy in science and technology

Teaching methods

Lecture: multimedia presentation during lecture and electronic documents containing presentation content in a condensed form made available to the students via e-mail.

Bibliography

Basic

1. Instrumenty optyczne, F. Ratajczyk, Oficyna Wydawnicza Politechniki Wrocławskiej, Wrocław 2002
2. Optyka, E. Hecht, Wydawnictwo Naukowe PWN, Warszawa 2012
3. Mikroskopia optyczna, M. Pluta, Państwowe Wydawnictwo Naukowe, Warszawa 1982

Additional

1. Springer Handbook of Lasers and Optics, Editors: Frank Träger, Springer Berlin Heidelberg 2012

Breakdown of average student's workload

	Hours	ECTS
Total workload	54	2,00
Classes requiring direct contact with the teacher	28	1,00
Student's own work (literature studies, preparation for laboratory classes/ tutorials, preparation for tests/exam, project preparation)	26	1,00